



ZFW AF

MAIL STOP AF
PATENT
8040-1022

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Hiroataka NAKANO et al.

Confirmation No. 9420

Serial No. 09/855,723

GROUP 2825

Filed May 16, 2001

Examiner Magid Y. Dimyan

SYSTEM OF MANUFACTURING SEMICONDUCTOR
INTEGRATED CIRCUIT

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 7, 2004

Sir:

Responsive to the Official Action of April 16, 2004,
please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this
paper.

Amendments to the Claims are reflected in the listing
of claims that begins on page 4 of this paper.

Remarks begin on page 15 of this paper.

An **Appendix** is attached which follows the signature page
of this paper.